

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kazuhiro TAKAHASHI et al.

Application No.: 09/749,926

Filed: December 29, 2000

For: EXPOSURE APPARATUS

) : Examiner: H. Nguyen
): Group Art Unit: 2851
):
):
): February 24, 2003

Commissioner for Patents
Box RCE
Washington, D.C. 20231

THO/HB
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PRELIMINARY AMENDMENT

Sir:

Prior to further examination on the merits, please amend the above-identified application as follows:

IN THE CLAIMS:

Please ADD new claims 14-16, as follows. For the Examiner's convenience, all claims currently pending in this application have been reproduced below:

1. An exposure apparatus, comprising:
a light source;